Call for Papers

ASPE

40th Annual Meeting

Omni San Diego San Diego, California, USA Monday-Friday, November 3-7, 2025

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John S. Taylor, University of North Carolina at Charlotte

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ASPE's 40th Annual Meeting will be at the Omni-San Diego in the heart of the Gaslamp Quarter

ASPE has a proactive and conscious commitment to determinism and expertise in precision engineering. For this 40th Annual Meeting, we will feature a Special Opening Session offering senior perspectives on how these fundamental concepts have proven invaluable.

Special Opening Session

John S. Taylor Introduction: Perspective on Determinism and

Precision Engineering

Determinism as a Catalyst for Creative. Alexander Slocum

Effective Precision Design

Stuart T. Smith Instrumentation and Mechanisms:

Finding the Ceiling

Jelm Franse The Best Recipe for Developing Mechatronic

Systems with World-Class Performance

Jeffrey W. Roblee Applying the Principles of Precision

& Mark Stocker Engineering to Enhance the Repeatability of

Machine Tools

Brigid A. Mullany Determinism in Manufacturing: A Surface

Scan Can Reveal a Multitude

Edward P. Morse Determinism and Documentary Standards

We are soliciting papers in:

- · Controls and Mechatronics
- Metrology Systems & Surface Characterization
- Precision Design
- · Precision Manufacturing
- Micro-Nano Technologies
- Applications of Precision Eng. & Measurement Science

Conference Highlights Include:

- Industrial Exhibits
- Extensive Tutorial Program
- Student Challenge & Scholarships

Short Abstract Due Date: June 2, 2025

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